



PATENT

Docket No. 149-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors: Horiuchi et al.

Serial No.: 09/881,005

Filed: June 14, 2001

Title: MULTI-LAYERED
SEMICONDUCTOR DEVICE
AND METHOD FOR
PRODUCING THE SAME

Examiner: Doug Owens

Art Unit: 2811

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AFTER FINAL AMENDMENT UNDER 37 CFR 1.116

Dear Sir:

This amendment is in response to the Office Action dated May 17, 2004 having a three-month statutory period for response set to expire on August 17, 2004. This amendment is being filed on or before the time period for response of August 17, 2004.

Please amend the application as follows:

IN THE CLAIMS

Please amend the claims pursuant to 37 C.F.R. § 1.121 (c) as per direction.

Applicant submits a marked copy of the changes to the claims attached hereto.

Please cancel claims 5-10, 12, 17 and 18.